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Dated: December 14, 2006 Signature: \_\_\_\_\_

(Fay Guarino)

Docket No.: 007734 FPS/MMCS/APC  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Young J. PAIK Confirmation No.: 6290  
Application No.: 10/665,165 Art Unit: 1763  
Filed: September 18, 2003 Examiner: S. MacArthur  
Title: FEEDBACK CONTROL OF A CHEMICAL MECHANICAL  
POLISHING PROCESS FOR MULTI-LAYERD FILMS

MS AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT AFTER FINAL ACTION UNDER 37 C.F.R. 1.116**

Dear Sir:

**INTRODUCTORY COMMENTS**

This is in response to the Office Action mailed June 16, 2006, having a response due by September 16, 2006. Applicants request a three-month extension of time to respond to the Official Action (i.e., to and including December 16, 2006), and enclose the appropriate fee in accordance with 37 C.F.R. §1.136(a). The following Remarks are respectfully submitted.

The Commissioner is authorized to charge any necessary fees or credit any overpayments to Deposit Account No. 08-0219.

**Remarks/Arguments** begin on page 2 of this paper.